



INSTYTUT TECHNOLOGII ELEKTRONOWEJ

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NARODOWA STRATEGIA SPÓJNOŚCI

UNIA EUROPEJSKA
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ROZWOJU REGIONALNEGO



DKZ/55/2009

Warsaw, 24.07.2009

The Institute of Electron Technology informs that the close examination of the offers submitted in the course of the open tendering procedure for the **delivery of the system for Reactive Ion etching with Inductively Coupled Plasma (ICP) Sources**, has led to the selection of the offer presented by KARIA Sp. z o. o., ul. Pasteura 5A, 02-093 Warszawa, which was the only offer fulfilling the requirements.

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